



TED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

OZAKI, Takashi, et al.

Group Art Unit: 1763

Serial No.: 10/528,137

Examiner: Sylvia MacArthur

Filed: December 12, 2005

P.T.O. Confirmation No.: 2307

For:

SUBSTRATE APPARATUS PROCESSING AND METHOD FOR

MANUFACTURING A SEMICONDUCTOR DEVICE

<u>PETITION FOR EXTENSION OF TIME</u>

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Date: August 27, 2007

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated July 18, 2007 for one month, from August 18, 2007 to September 18, 2007.

The Commissioner is authorized to charge our Deposit Account No. 01-2340 in the amount of \$120.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

KRATZ, QUINTOS & HANSON, LLP

Mel R. Quintos

Attorney for Applicants

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Reg. No. 31,898

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MRQ/lrj

Atty. Docket No. 050161 Suite 400 1420 K Street, N.W. Washington, D.C. 20005 (202) 659-2930

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PATENT TRADEMARK OFFICE